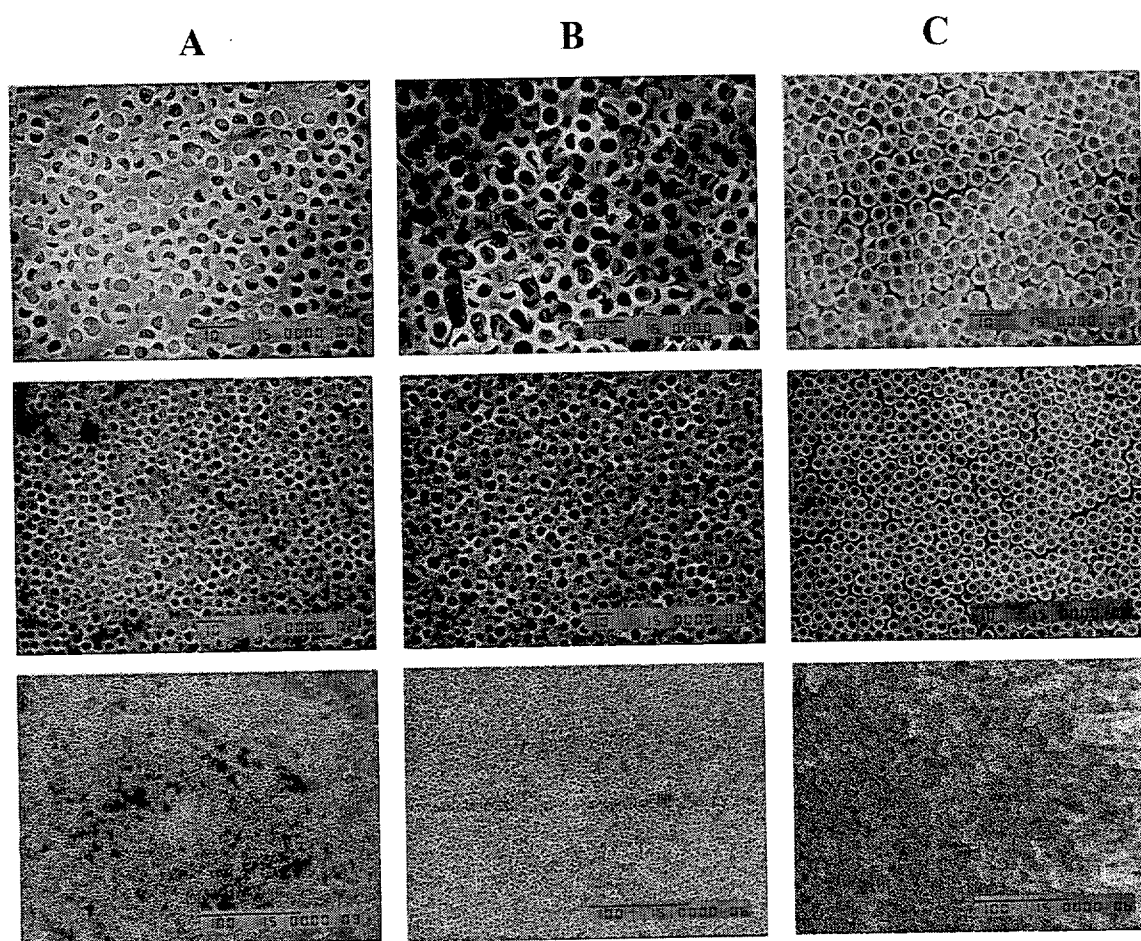
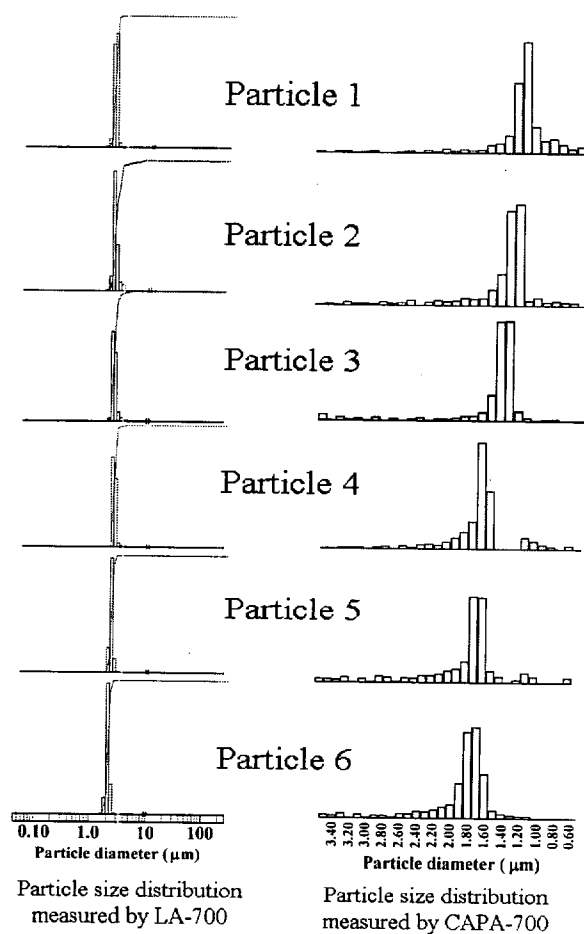


### Supporting information

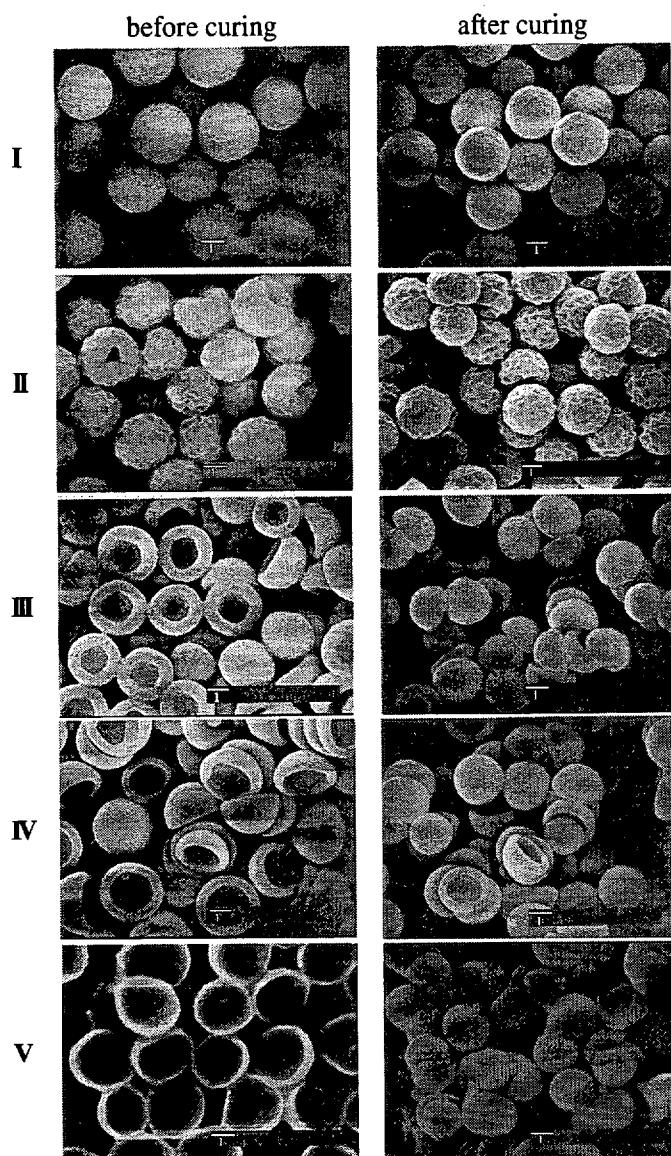
1. **Figure 1** shows the time-course of the fabrication of mercapto-functionalized hemisphere.
2. **Figure 2** indicates that aggregation of hemispheres was not observed by measuring the particle size distribution.
3. **Figure 3** indicates how the morphology would be varied by the pyrolysis at 900°C.
4. **Figure 4** shows that the second weight loss of hemispheres increases as the amount of  $\text{RSiO}_{3/2}$  and  $\text{RSi(OH)O}_{2/2}$  units formed by GTS increases.
5. **Figure 5** indicates SEM images of microstructures patterned by compression micromolding using a rigid structure on the mold rather than an elastometric one.
6. **Figure 6** shows SEM images of microstructure fabricated by curable compression micromolding and curable cast micromolding using the thin-layer materials as a master.
7. **Table 1** indicates the recipes for polymerization of particles **1 – 10** described in **Figures 1, 2, 4, 5** and **6**.



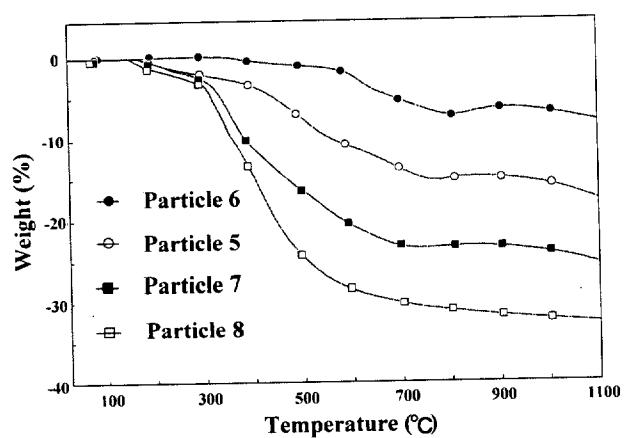
**Figure 1.** The time-course of the fabrication of mercapto-functionalized hemisphere **10** with an average major axis of  $5.0\ \mu\text{m}$ . The thin-layer materials were obtained by casting a colloid solution of the particles on the metal at regular time intervals. (A) SEM images after a period of approximately 10 hr. (B) after approximately 24 hr. (C) after about 36 hr.



**Figure 2.** Particle size distribution of organic-functionalized hollow hemispheres 1 – 6 of methylsilsesquioxane derivatives obtained by suspension polymerization were measured by LA-700 and CAPA-700, respectively.

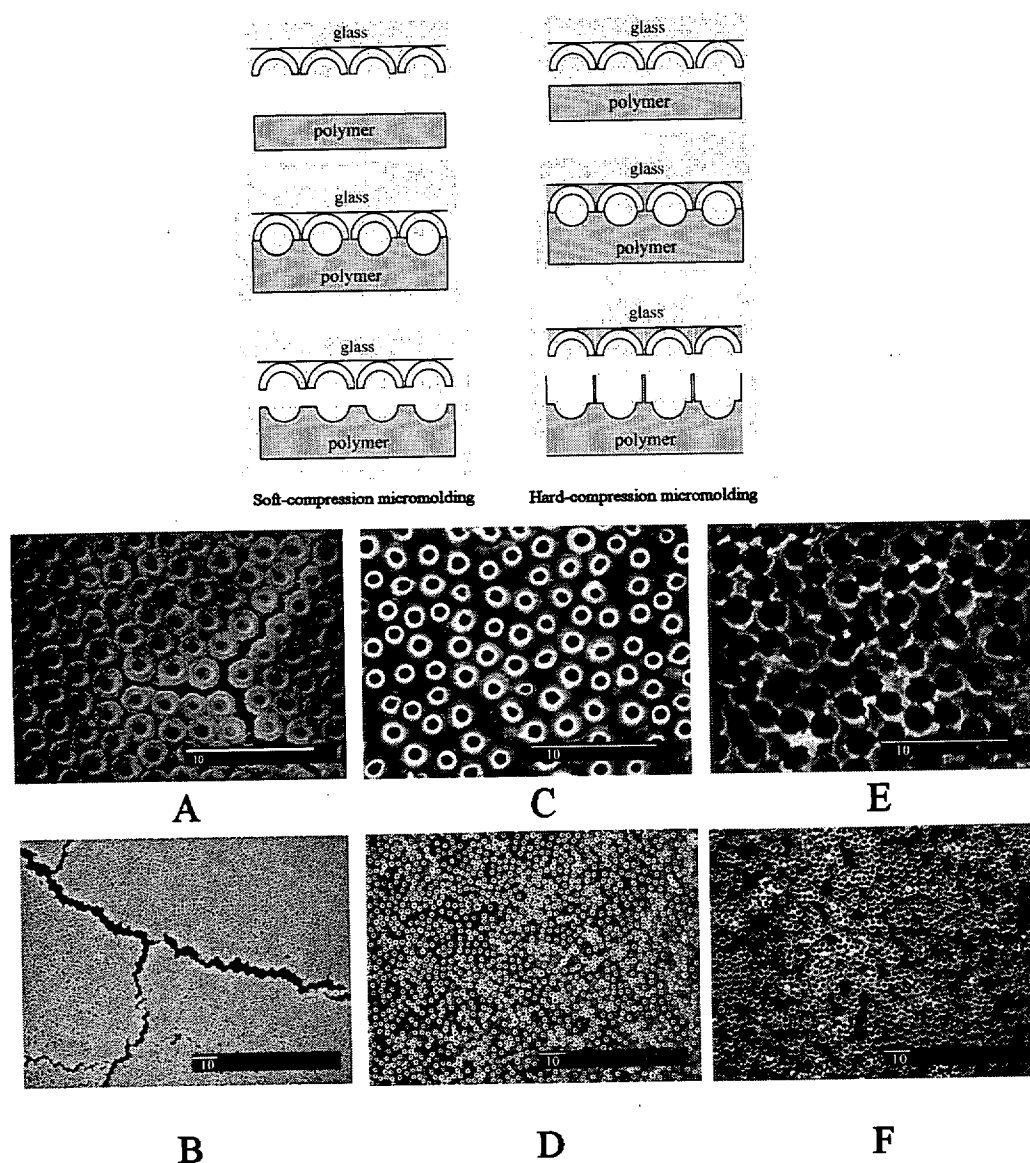


**Figure 3.** SEM images of methylsilsesquioxane derivatives upon curing at 900 °C under nitrogen atmosphere. All photographs enlarged  $\times 10000$  times. The marker bars are 1.0  $\mu\text{m}$ . Empirical formulas of particles I - V were,  $\text{R}_{0.9}\text{SiO}_{1.55}$ ,  $\text{R}_{0.8}\text{SiO}_{1.60}$ ,  $\text{R}_{0.7}\text{SiO}_{1.65}$ ,  $\text{R}_{0.6}\text{SiO}_{1.70}$ , and  $\text{R}_{0.5}\text{SiO}_{1.75}$ , respectively.

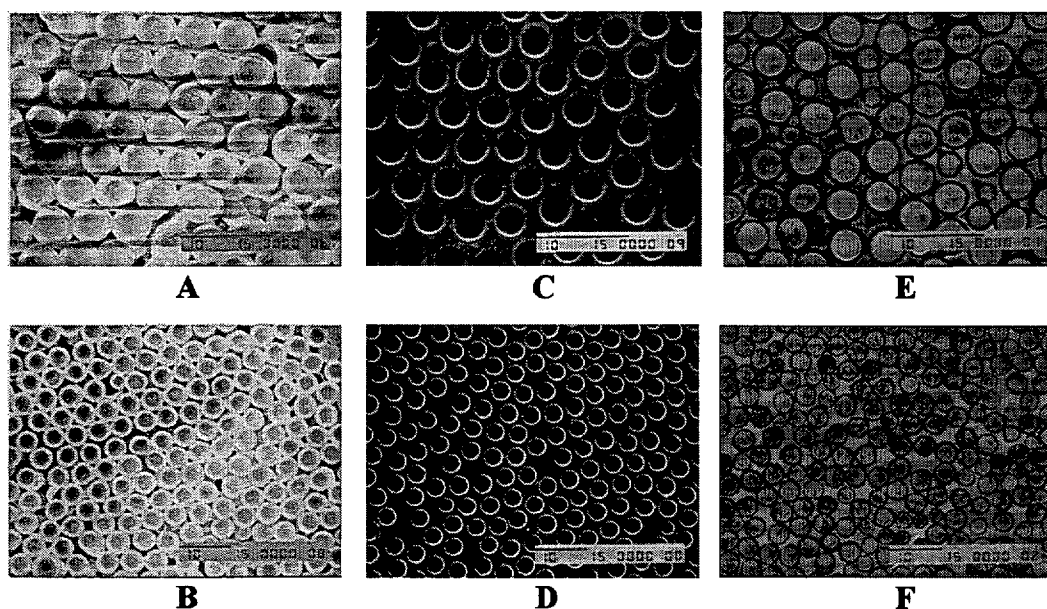


**Figure 4.** TGA curves of particles 5, 7, and 8 compared with hemisphere 6.

**Scheme 1. Soft- and hard-compression micromolding**



**Figure 5.** SEM images of nanostructure of hemisphere 1 on a master, polycarbonate replicas prepared by soft-compress and hard-compress micromolding, as shown in Scheme 1. (A, B) The thin-layer material as a rigid structure on the master rather than an elastometric one. (C, D) polycarbonate replica patterned by soft-compress micromolding. (E, F) polycarbonate replica embossed by hard-compress micromolding.



**Figure 6.** SEM images of microstructures of hemisphere **10** with an average major axis of 5.0  $\mu\text{m}$  on a master, polymer replica fabricated by curable compression micromolding, and polymer replica obtained by curable cast micromolding. (A, B) The thin-layer material on a glass. (C, D) The replica of poly(4-acryloylmorpholine) obtained by curable compression micromolding. (E, F) The replica of poly(4-acryloylmorpholine) patterned by curable cast micromolding.

**Table 1. Particles 1–10 Prepared by Polymerization under Constant Concentration of NaOH (0.020wt % per water)**

particle	MTS (mol)	TOES (mol)	GTS (mol)	MATS (mol)	MCTS (mol)	median diameter (μm)	
						LA-700	CAPA-700
<b>1</b>	0.43	0.38		0.032		2.14	1.18
<b>2</b>	0.43	0.38	0.034			2.25	1.34
<b>3</b>	0.57	0.38				2.25	1.44
<b>4</b>	0.52	0.29		0.032		2.11	1.64
<b>5<sup>a</sup></b>	0.52	0.29	0.034			2.18	1.68
<b>6</b>	0.67	0.29				2.13	1.72
<b>7</b>	0.43	0.29	0.069			2.43	1.99
<b>8</b>	0.35	0.29	0.104			2.21	1.71
<b>9<sup>a</sup></b>	0.43	0.38			0.046	2.41	1.64
<b>10</b>	0.43	0.38			0.046	5.02	3.76

<sup>a</sup>Particle 5 and 9 correspond to particles 8 and 10 in this report, respectively. <sup>b</sup>Particle 10 was obtained by polymerization using sodium hydroxide (0.0069 wt % per water).